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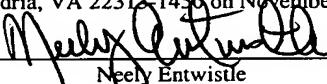
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)
REDEKER et al.) Examiner: Unassigned
Application No. 10/734,704) Art Unit: 2812
Filed: December 12, 2003) Docket No. LAM2P461
For: METHOD AND APPARATUS FOR) Date: November 23, 2004
SEMICONDUCTOR WAFER PLANARIZATION)

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 23, 2004.

Signed: 
Neely Entwistle

REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST &
NOTICE OF FOREIGN FILING

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

A request that the above-identified application not be published under 35 U.S.C. 122(b) (non-publication request) was included with the above-identified application on filing pursuant to 35 U.S.C. 122(b)(2)(B)(i).

I hereby **RESCIND** the previous non-publication request. If a **notice of foreign or international filing** is or will be required by 35 U.S.C. 122(b)(2)(B)(iii) and 37 CFR 1.213(c), I hereby provide such **NOTICE**. This notice is being provided no later than forty-five (**45**) days after the date of such foreign or international filing.

Respectfully submitted,
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